

PATENT ABSTRACTS OF JAPAN

(11)Publication number : 2002-008166

(43) Date of publication of application : 11.01.2002

(51)Int.Cl.

G08B 25/00

(21)Application number : 2000-192931

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(22)Date of filing : 27.06.2000

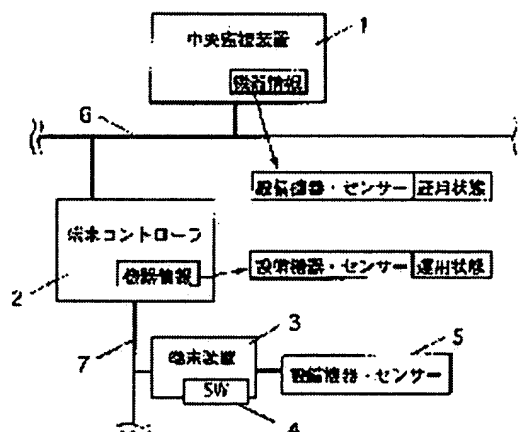
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(54) MONITORING CONTROL SYSTEM

(57)Abstract:

PROBLEM TO BE SOLVED: To provide a monitoring control system capable of easily confirming test operation of a sensor device and facility equipment without using an exclusive inspection device during the operation of the system.

SOLUTION: This monitoring control system performs monitoring control of terminal units 3 by a central monitoring device 1 by dispersing and installing the terminal units 3 in an object 5 to be monitored and controlled such as the sensor device and facility equipment. A switching means 4 switching setting of an operation mode operating the terminal units as at least a test condition is provided in the terminal units 3 as shown in Fig. 1, and the central monitoring device 1 excludes processing for interlocking the terminal units 3 with the other object 5' to be monitored and controlled when detecting that a setting condition of the operation mode by the switching means 4 is a test operation mode.



LEGAL STATUS

[Date of request for examination]

[Date of sending the examiner's decision of

rejection]

[Kind of final disposal of application other than
the examiner's decision of rejection or
application converted registration]

[Date of final disposal for application]

[Patent number]

[Date of registration]

[Number of appeal against examiner's
decision of rejection]

[Date of requesting appeal against examiner's
decision of rejection]

[Date of extinction of right]

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